



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
United States Patent and Trademark Office
Address: COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, Virginia 22313-1450
www.uspto.gov

BIBDATASHEET

CONFIRMATION NO. 2605

Bib Data Sheet

SERIAL NUMBER 10/617,114	FILING DATE 07/09/2003 RULE	CLASS 438	GROUP ART UNIT 2823	ATTORNEY DOCKET NO. 200208154-1
-----------------------------	-----------------------------------	--------------	------------------------	---------------------------------------

APPLICANTS

Jian-gang Weng, Corvallis, OR;

Ravi Prasad, Corvallis, OR;

Cary G. Addington, Albany, OR; Man Ho Cheung, Singapore, SINGAPORE;

** CONTINUING DATA *BR, NONE*** FOREIGN APPLICATIONS *BR, NONE*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 10/06/2003

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY OR	SHEETS DRAWING 5	TOTAL CLAIMS 32	INDEPENDENT CLAIMS 3
Verified and Acknowledged Examiner's Signature <i>BSL</i>	Initials				

ADDRESS

HEWLETT-PACKARD COMPANY
Intellectual Property Administration
P.O. Box 272400
Fort Collins, CO
80527-2400

TITLE

Solution-processed thin film transistor formation method

FILING FEE RECEIVED 966	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
-------------------------------	---	---